

34.1 THz Cryo-CMOS Backscatter Transceiver: A Contactless 4 Kelvin-300 Kelvin Data Interface

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Modern low-temperature large-scale systems, such as high-sensitivity IR/THz imaging arrays and quantum computers, require massive signal connections between the cooled system core and external room-temperature (RT) components. An error-protected quantum computer needs thousands or even millions of qubits operating at cryogenic temperature. Albeit the rapid development of highly-integrated quantum processors [1], future scalability may still be largely limited by the cables connecting the processors and peripheral control/processing units [2]; because even using low-thermal-conductivity metal materials, those cables still transport non-negligible amount of heat due to the large temperature gradient. In a dilution refrigerator, a stainless-steel UT-085-SS-SS cable could pose close to one mW of heat load to the 4K stage, and tens of mW to the 50K stage [2]. To drive such a non-copper cable in the cryogenic-to-RT (i.e. uplink) data path, standard I/O circuits in cooled sensors/processors typically consume pJ/b-level energy, further raising the overall heat load. Recently, optical fibers along with cryogenic InGaAs photodiode [3] and VCSEL lasers [4] are used for <20mK coherent qubit control/readout mode and 4K-to-300K uplink data mode, respectively. The energy consumption in [4] reduces to 406.2fJ/b at 10Gbps and <10⁻¹² bit-error-rate (BER). In this paper, a terahertz (THz) transceiver chip operating at 4K is presented as a CMOS-based, fully-integrable alternative to the interconnect solutions above. The carrier frequency of 260GHz, which is determined based on the trade-off between the antenna dimension and the efficiency of the transistors, is sufficiently high to minimize the link footprint and to avoid potential disturbance of qubits, such as the superconducting or nitrogen-vacancy ones, that typically operate at gigahertz; on the other hand, it also leads to much lower quantum noise ($\sim\hbar\omega$) compared to that in photonic links. The transceiver avoids the power-hungry terahertz (THz) generation by adopting a passive backscatter communication scheme (Fig. 34.1.1), and a 4Gbps uplink is demonstrated with only 176fJ/b added heat load. In the downlink, the heat load is further reduced to 34fJ/b at 4.4Gbps. This fully contactless 4K-RT interface can be used to deliver digitized control/readout data, and even some analog/RF signals such as low phase noise clocks.

The architecture of the chip is shown in Fig. 34.1.2, which is based on a 2x2 quad-feed patch antenna array. Each patch has a square shape, leading to an identical resonance frequency of 260GHz for waves polarized in either X- or Y- directions. Three orthogonal edges of the patch are connected through a pair of FinFET switches M_1 , M_2 and wavelength (λ)-long transmission lines TL_1 , TL_2 . The fourth edge of the patch is connected to a THz detector. In the uplink mode, the detector is deactivated and presents a reactive impedance that reflects any antenna-received wave back. The uplink mode is enabled when the digital control $A, B=1, 1$. Shown in Fig. 34.1.2, in this mode, the THz switches are toggled by the uplink input data TX_{IN} , and the incident wave polarized in the Y-direction excites the antenna TM_{10} mode. When $TX_{IN}=0$, the wave is routed via TL_1 and M_1 to the left edge of the patch and then re-radiated through the antenna TM_{100} mode with polarization in the X-direction. In this state, the disconnected M_2 and the λ -long TL_2 present open to the top edge of the patch, hence avoiding disturbance to the backscatter process. Similarly, when $TX_{IN}=1$, the wave is routed to the right edge of the patch, but now the re-radiated wave possesses the opposite phase. The compact antenna structure therefore realizes binary phase-shift keying (BPSK) modulation and cross polarization in the backscatter communication; the latter reduces direct leakage from the THz source to the THz receiver located at 300K (Fig. 34.1.1).

Note that the power consumption of the uplink is dominated by the CV^2f dynamic power of the THz switches. Narrower switch reduces such power, but increases the THz power dissipation inside the switch, which also adds heat load. Based on the simulated data in Fig. 34.1.3, the switch width is set to 1.08 μ m. In Fig. 34.1.2, with $A, B=1, 0$, M_1 is always OFF, and the chip can operate in on/off keying (OOK) uplink mode, which leads to higher BER but lower dynamic switching power. Lastly, we note that the link budget of backscatter communication is proportional to the square of antenna radiation efficiency η , which is only 38% at 300K. Fortunately, with the large electrical conductivity increase of copper at 4K, the simulated η improves to 97% (Fig. 34.1.2). To achieve a larger radiation aperture and to avoid out-of-aperture THz power injection into the cryostat, a custom-designed horn antenna with a large flange shield is implemented using 3D metal printing. It is placed at the 60K stage in front of the chip without physical contact.

In the downlink mode, the digital control $A, B=0, 0$ turns off both M_1 and M_2 (Fig. 34.1.2), which then leads to open termination at three edges of the patch. Meanwhile, $A=0$ activates the THz square-law detector pair shown in Fig. 34.1.3 by applying a gate bias V_{GS} through an inverter. Exciting the TM_{10} mode of the antennas, the incident wave is

injected differentially into the THz detector. Based on a cold-FET detector topology, the detector at 4K achieves $\sim 4.5A/W$ current responsivity and $\sim 0.13pW/Hz^{1/2}$ noise equivalent power (NEP) in the simulation while consuming zero power. The faster device response, lower thermal noise and higher antenna efficiency lead to a $\sim 500x$ sensitivity increase compared to that operating at 300K. In Fig. 34.1.3, the detector bias node is a virtual ground created by the differential THz input signal, which prevents the impact of parasitics at that node on the THz detector. The 260GHz downlink carrier is OOK modulated. After the demodulation, the baseband signals from the detector pair become in-phase and are then injected into a chain of 80dB Ω transimpedance (TIA) amplifier, limit amplifier and a comparator. For testing purpose, a buffer stage is added for 50 Ω matching to the external instruments; it is not required in a future fully integrated cryogenic chip system.

The chip is fabricated using the Intel 22nm FinFET process and is designed with device models at 4K. The die size is 5.5mm². The chip is attached to a round PCB with a diameter of 28mm, which is then mounted to the 4K cold-finger of a cryostat (Fig. 34.1.4). The THz radiation is coupled into and out of the chip through a horn antenna and the glass window of the cryostat. The setup of the uplink measurement (Fig. 34.1.4) utilizes a VDI amplifier-multiplier chain (AMC-681) to generate the 260GHz carrier, and a VDI sub-harmonic mixer to demodulate the backscattered wave. Their horn antennas are placed with orthogonal E-planes. Single-tone signal and pseudo-random binary sequence (PRBS) data are fed into the chip from an arbitrary waveform generator. Figure 34.1.4 shows the down-converted BPSK backscatter spectrum, which gives a single-sideband SNR of 52.5dB at 100kHz resolution bandwidth (RBW) and indicates sufficient link budget for multi-Gbps transmission. Figure 34.1.4 also shows the SNR over various switching frequencies, as well as an eye diagram of demodulated BPSK data when a 4Gbps PRBS is fed to the chip. At 4Gbps, the OOK and BPSK modes provide <10⁻⁶ and <10⁻⁹ BER while consuming 305 μ W and 457 μ W of power, respectively. By monitoring the temperature rise of the cryostat with and without the external THz source (Fig. 34.1.6), we determine that the THz power injected into the cryostat is $\sim 400\mu$ W (with $\sim 50\mu$ W uncertainty), resulting in an overall heat load of 176fJ/b (OOK) and 214fJ/b (BPSK).

In the downlink measurement (Fig. 34.1.5), reduced THz power injection (<10 μ W) is performed to avoid chip receiver saturation, and the ~ 11 GHz input of the VDI-AMC is OOK modulated. First, with the VDI-AMC turned off, we see that the measured noise floor of the chip receiver output is reduced by 21dB from RT to 4K (Fig. 34.1.5). Then, with the VDI-AMC turned on, the chip receiver output power increases by 7.4dB from RT to 4K. These two values verify our previous prediction of 500x sensitivity improvement at 4K. With THz input, the noise floor at both temperatures is however all elevated, indicating that the SNR of the downlink (i.e. 49dB maximum at RBW=1MHz) is already limited by the noise of the VDI-AMC radiation, not the chip itself. Figure 34.1.5 shows an eye diagram of the chip output when the AMC is driven by a 4.4Gbps PRBS, and corresponds to a BER below 10⁻⁸. The downlink chip power is 149 μ W and the injected THz power is negligible, which leads to a heat load of 34fJ/bit. The heat load introduced by the horn antenna or the glass window is too small to be measured accurately. The performance of the work is summarized in Fig. 34.1.6. In light of the rapid advances of on-chip THz sources and receivers at room temperature [5], an all-silicon THz cryogenic link interface should be feasible in the future. The extensibility towards larger system sizes may also benefit by replacing free space coupling with thermal insulating THz dielectric-waveguide link [6].

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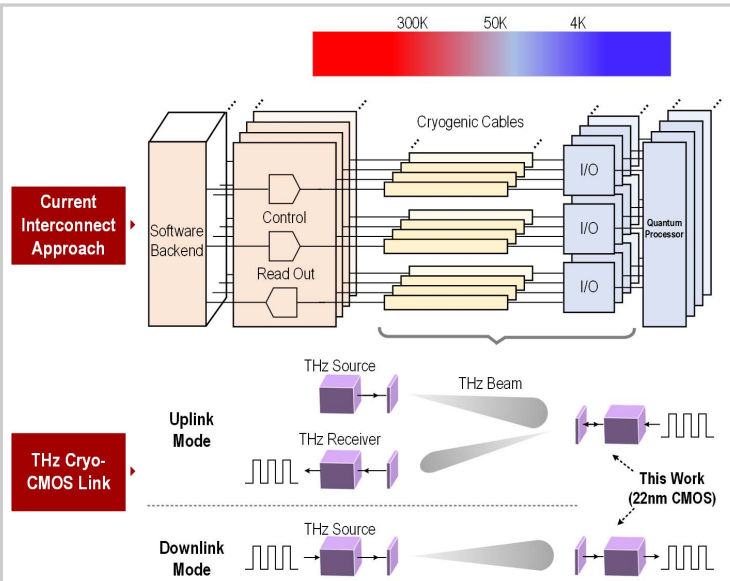


Figure 34.1.1: Overview of the presented contactless link replacing cryogenic cables in a cooled system.

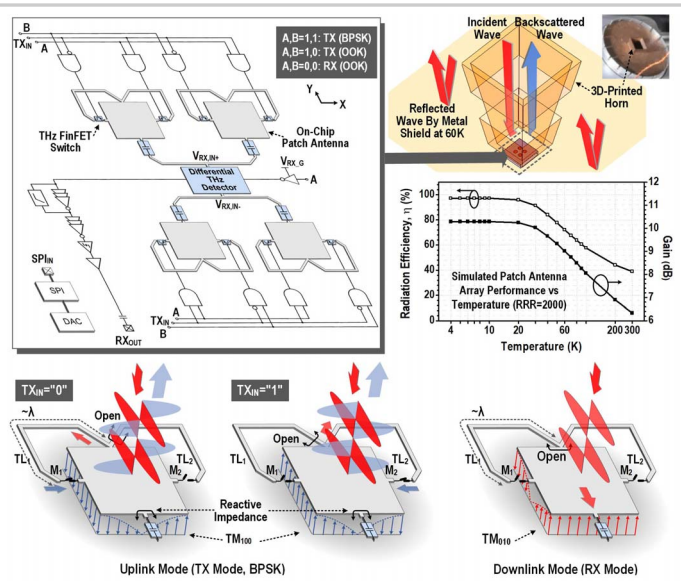


Figure 34.1.2: System diagram of the THz cryo-CMOS link and the modes of operation.

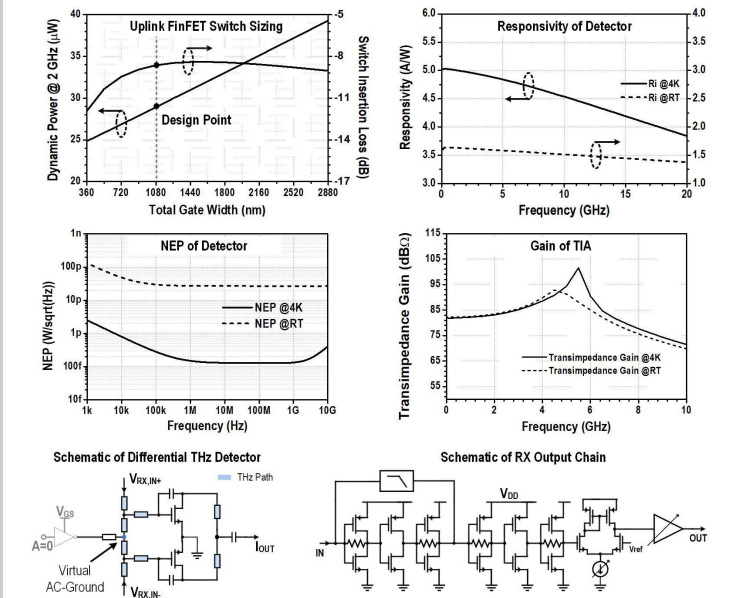


Figure 34.1.3: Simulated results of circuit blocks and the schematics of the receiver.

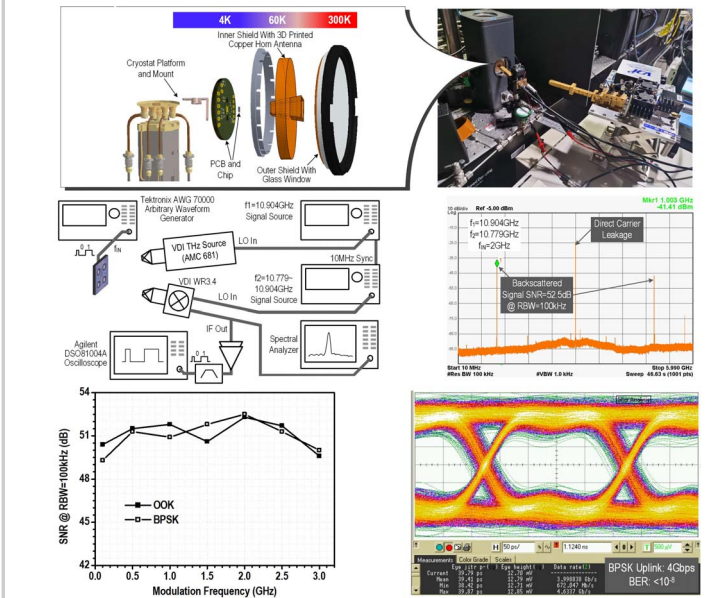


Figure 34.1.4: Uplink measurement setup and results.

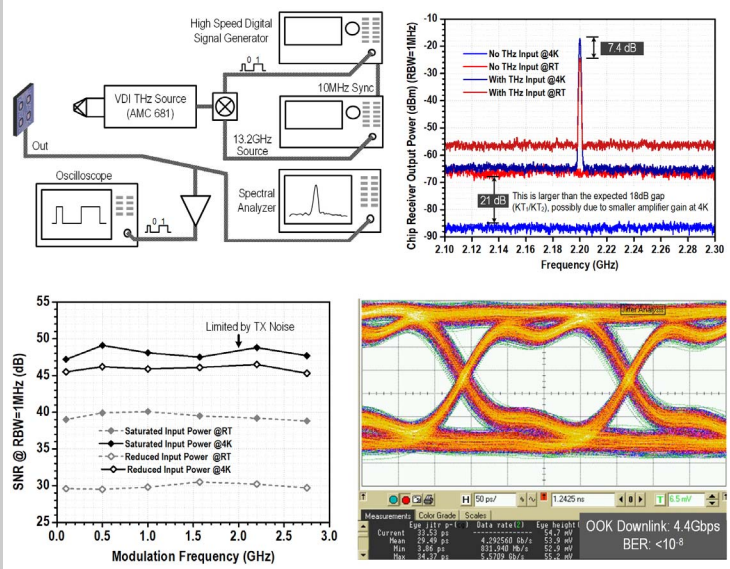


Figure 34.1.5: Downlink measurement setup and results.

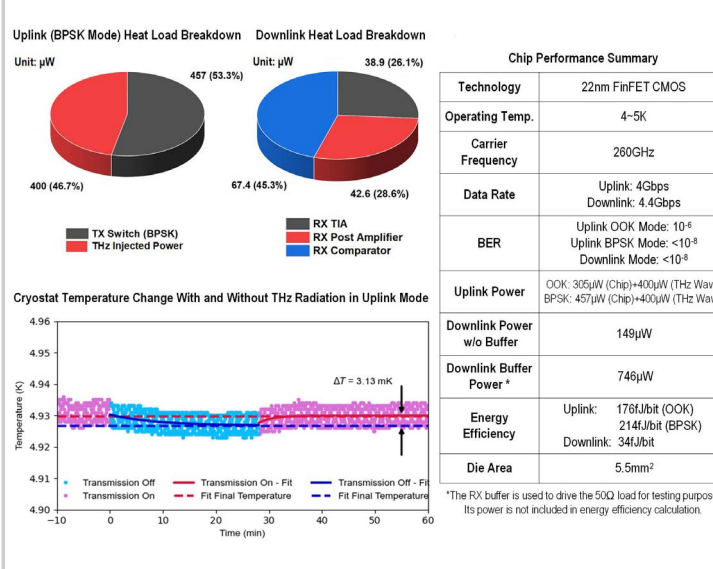


Figure 34.1.6: Power consumption breakdown of the RX and TX, temperature variation of the cryostat due to the THz radiation, and performance summary.

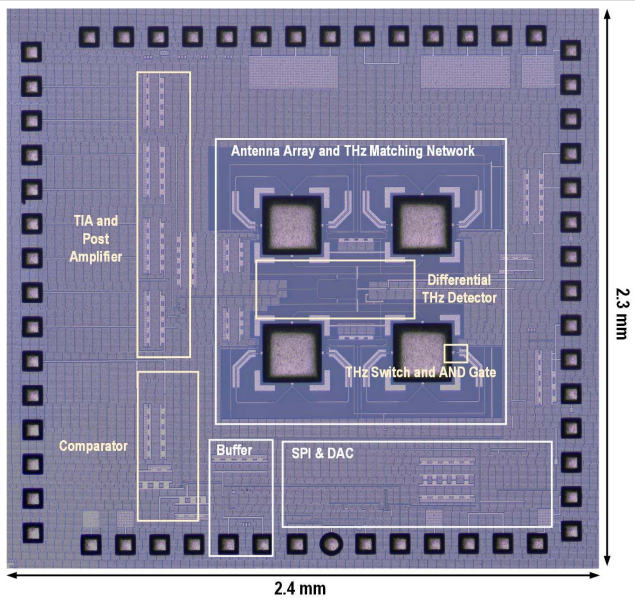


Figure 34.1.7: Die micrograph.